[54]	INTERFEROMETER OPTICAL SYSTEM	
[76]	Inventor:	Jacques E. Ludman, 98 Old Lowell Road, Westford, Mass. 01886
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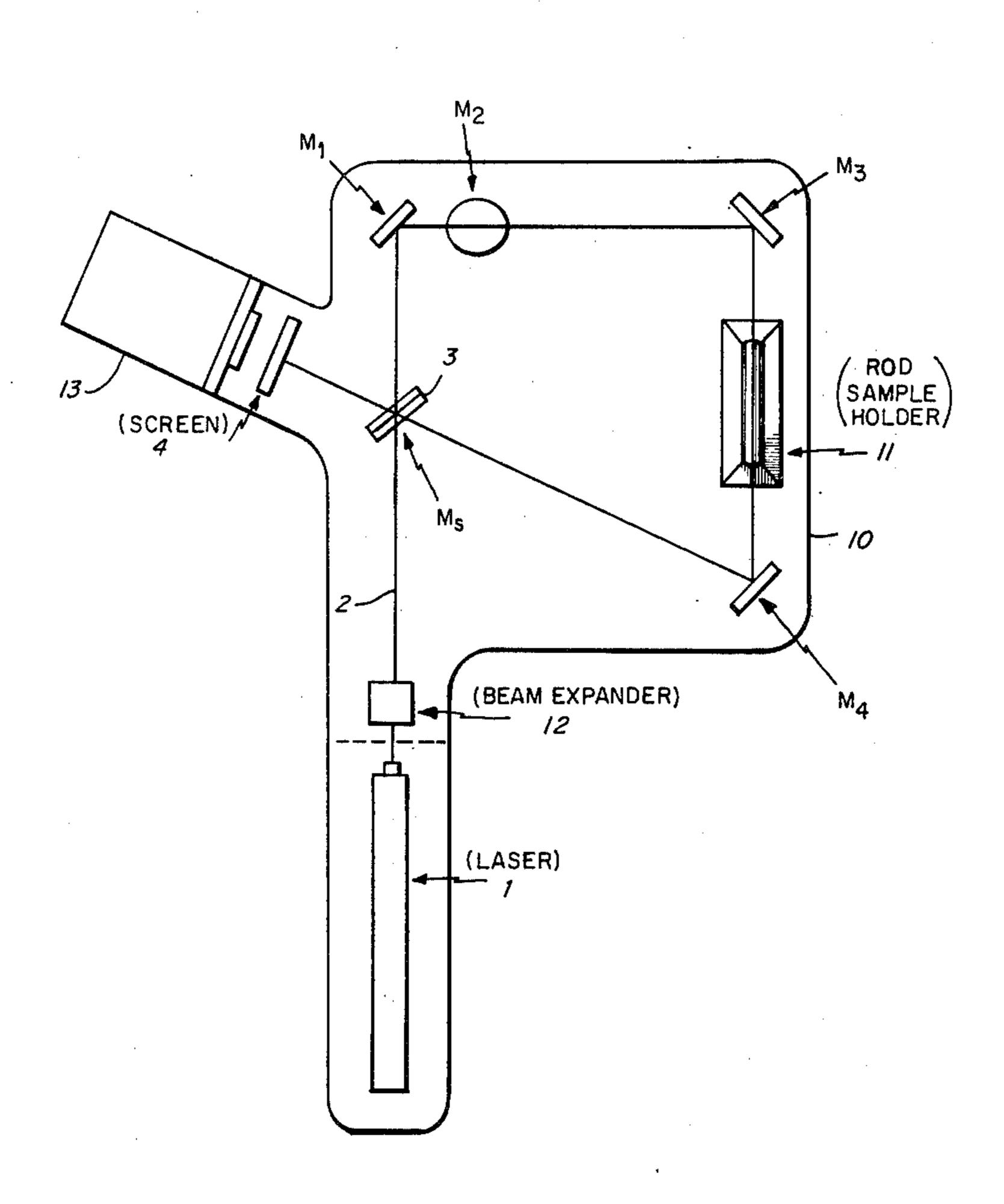
Primary Examiner—John K. Corbin
Assistant Examiner—Matthew W. Koren

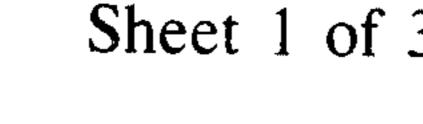
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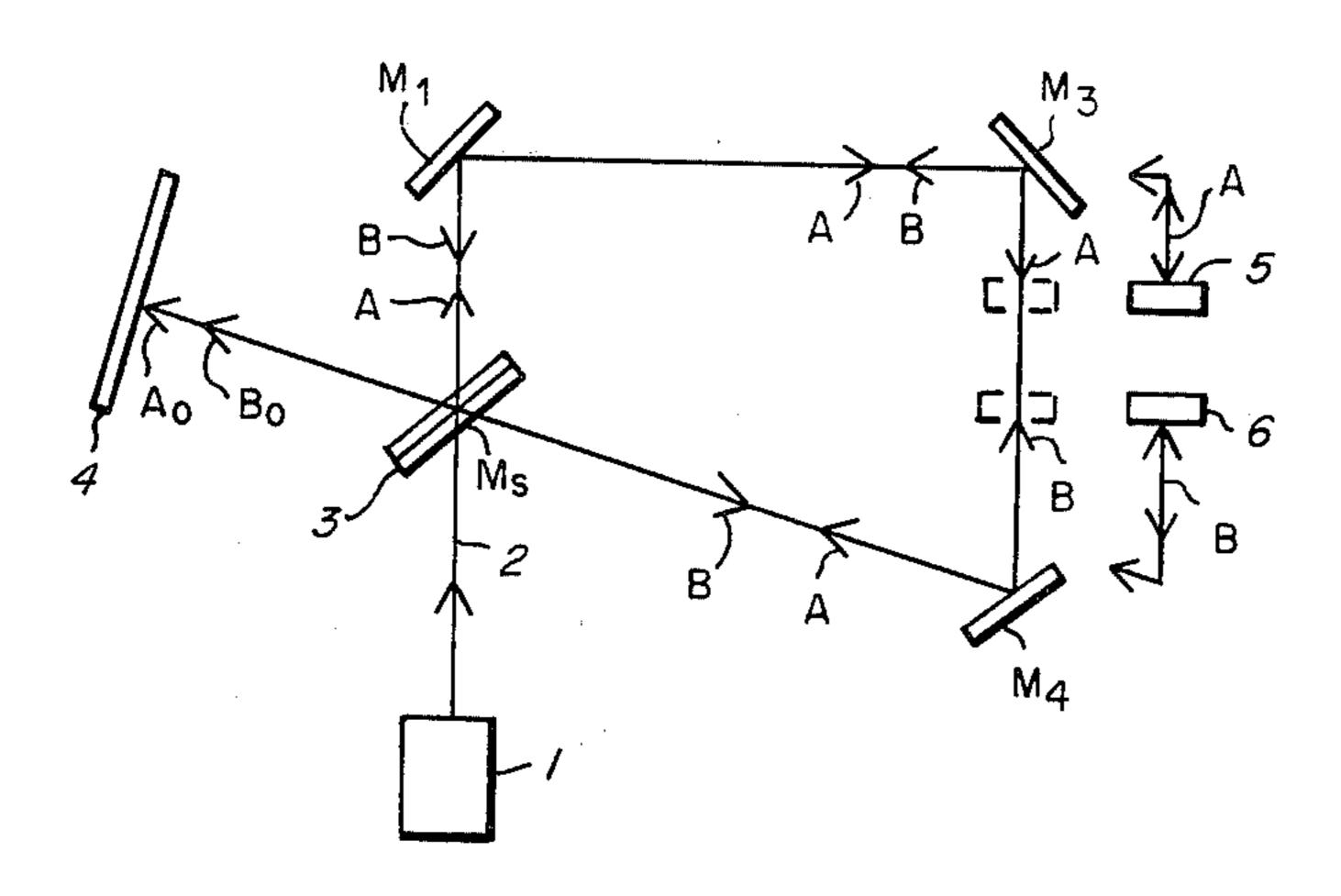
[57] ABSTRACT

An interferometer optical system for general use to measure optical parallelism or relative rotational or joint translational positions of the two spaced subject mirrors uses coherent light split into two beams which are directed, one normal to one of the two mirrors and the other normal to the other of the two mirrors. The reflections of these two beams are then superimposed on a target which reveals a light interference pattern indicative of the parallelism or relative rotation or joint translation of the two mirrors. In preferred embodiments, in order to compensate for the mutual tilt of the subject mirrors with respect to the plane of the beams incident thereon, the path of one of the beams to and from the subject mirror includes a corner mirror, or retrodirective mirror, and the path of the other beam includes at least one adjustable mirror.

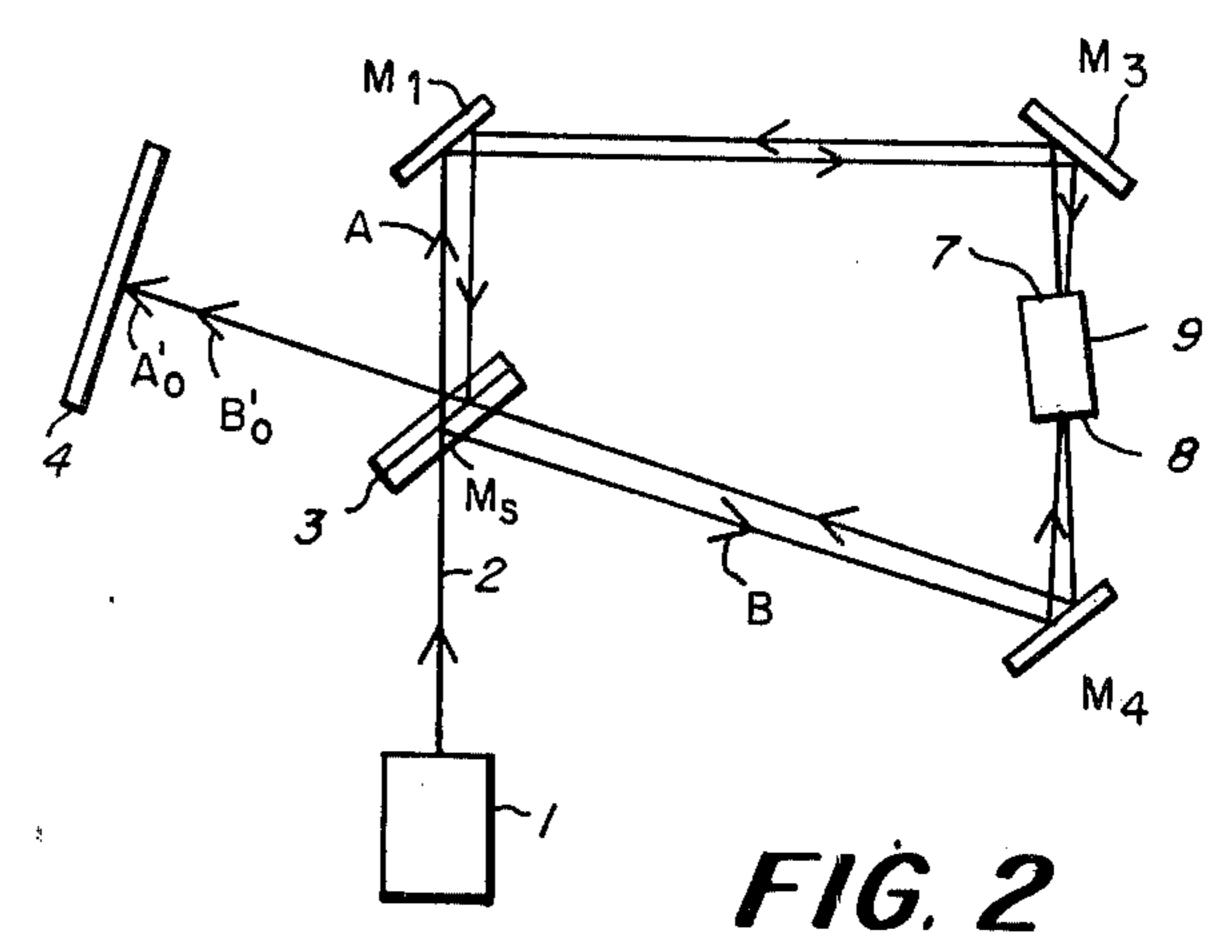
8 Claims, 11 Drawing Figures

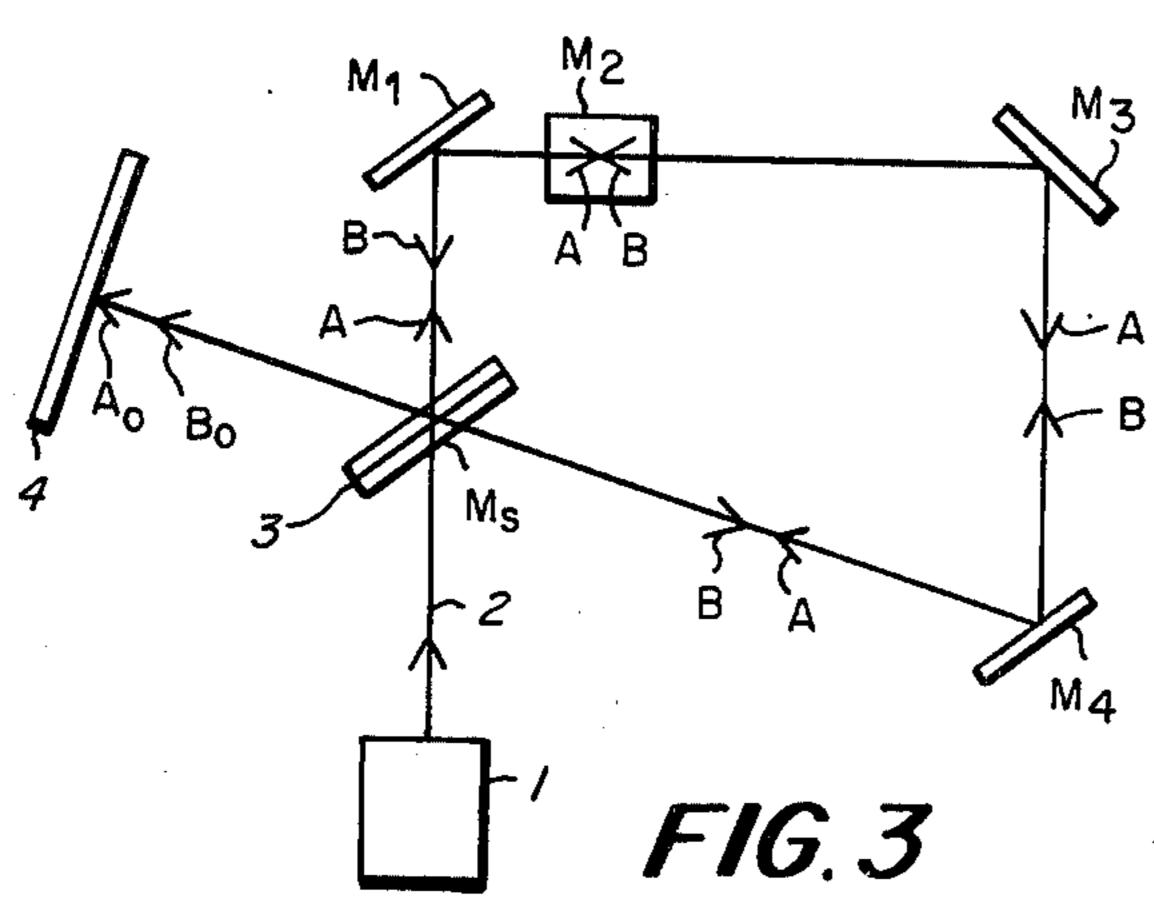


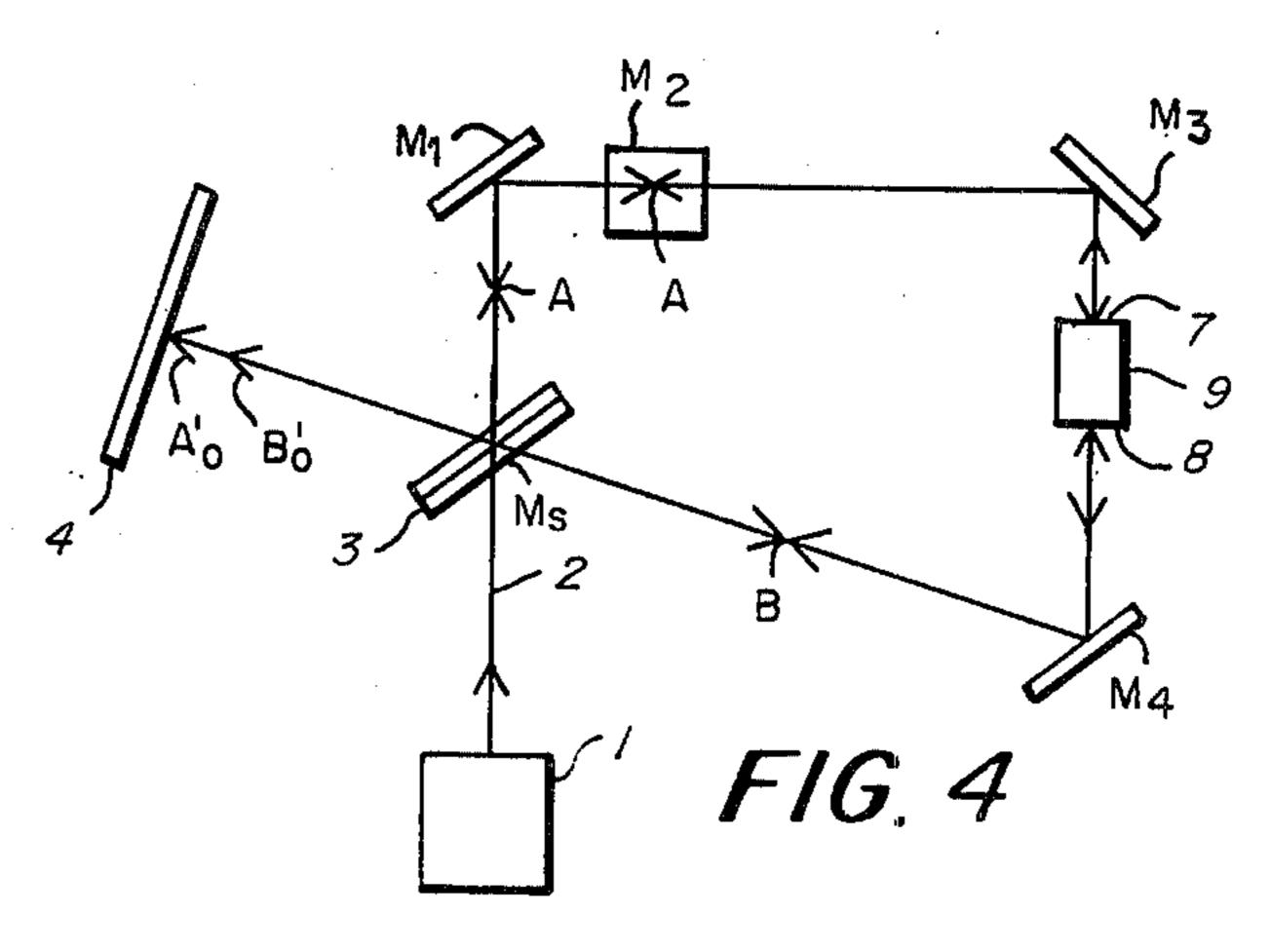


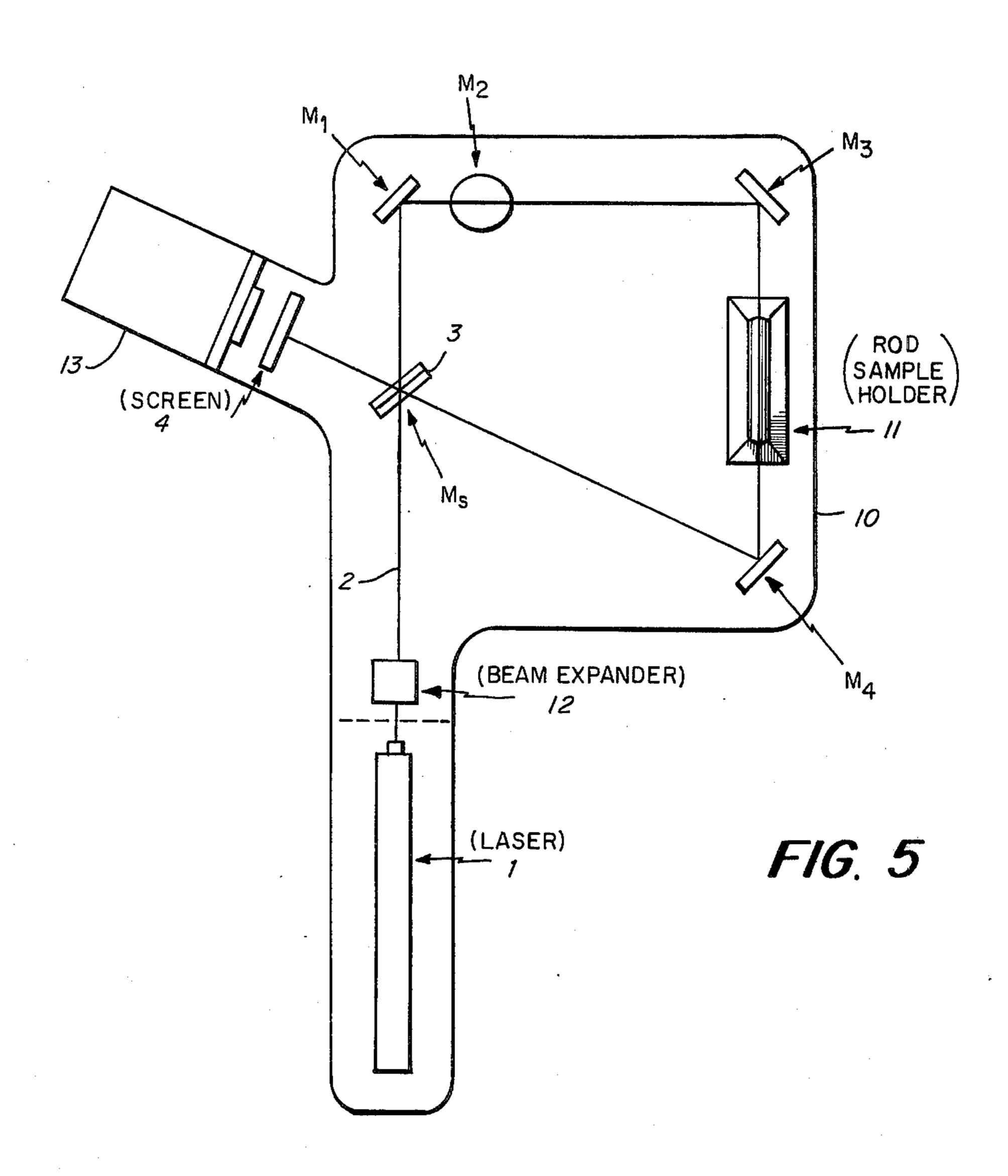


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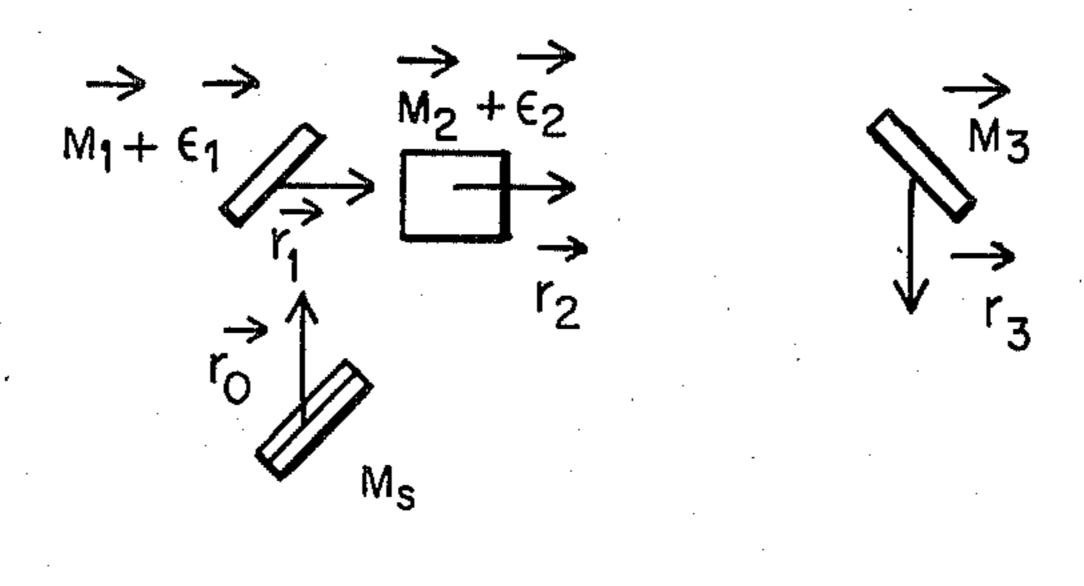






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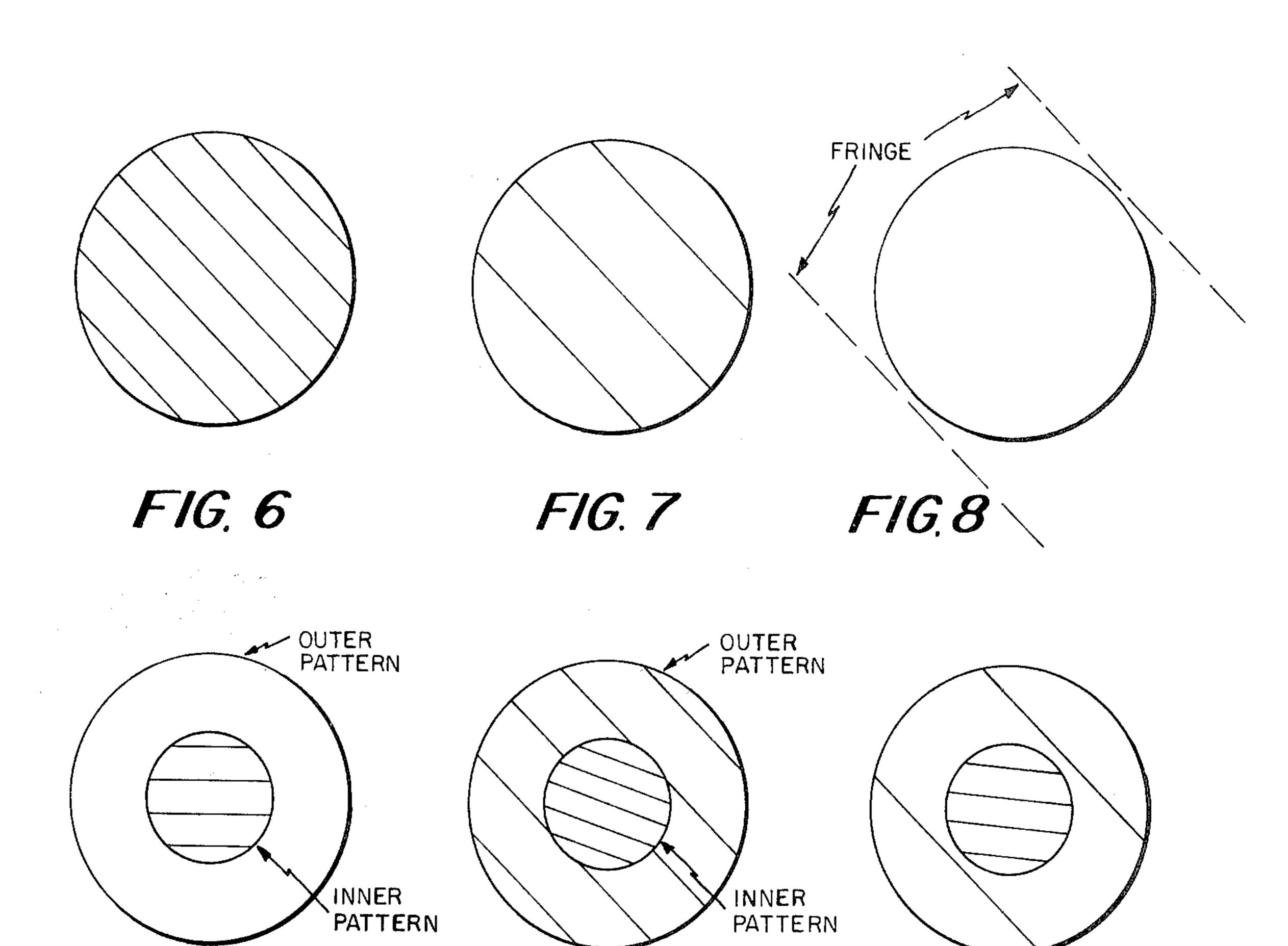
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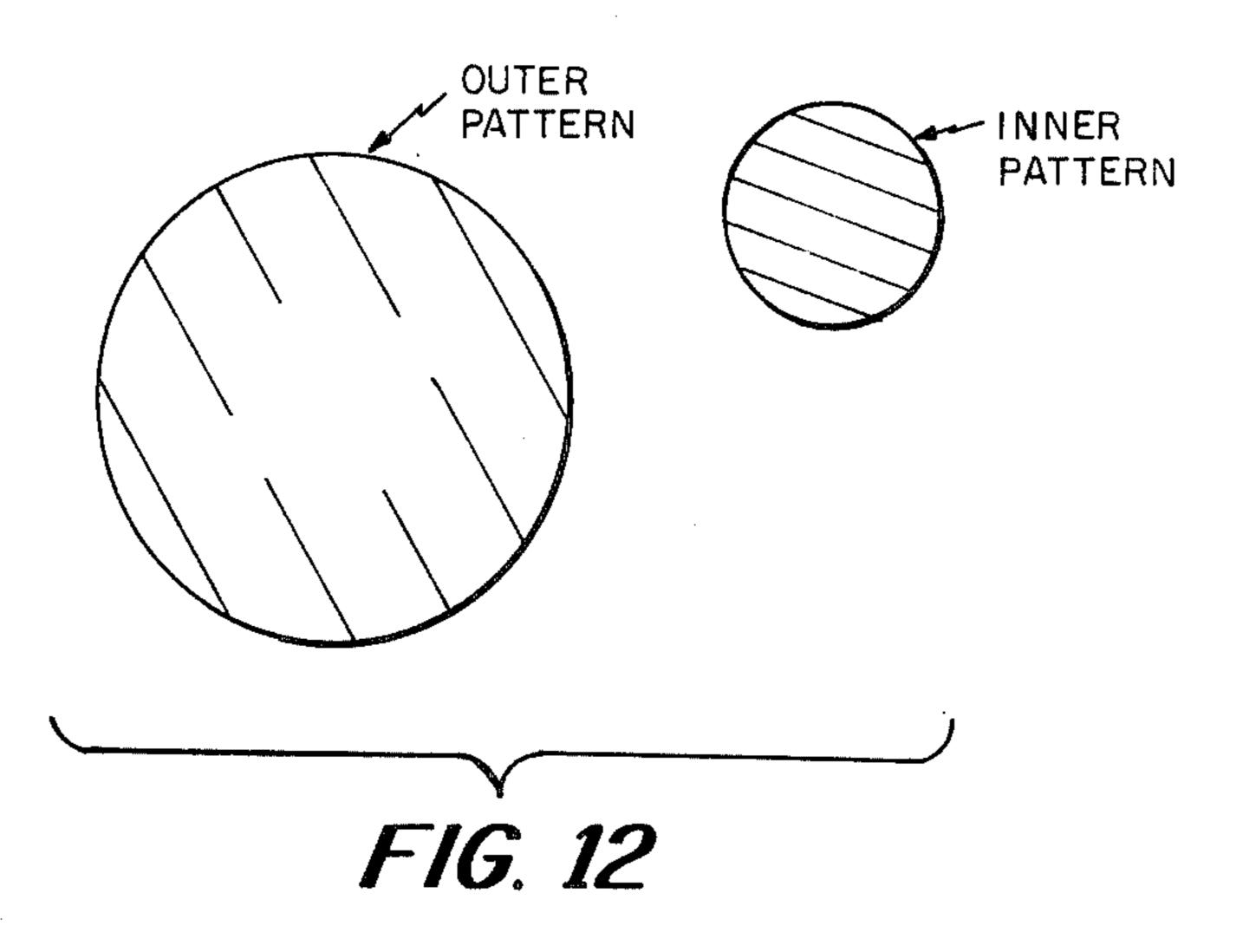




F16. 9

F1G. 11





F1G. 10

INTERFEROMETER OPTICAL SYSTEM BACKGROUND OF THE INVENTION

This invention relates to interferometers, and particu-5 larly, to a method and means for measuring the parallelism or relative rotational or joint transational positions of two subject mirrors.

A laser optical cavity requires a high degree of parallelism between two opposing reflective interfaces or 10 mirrors along the optical axis of the laser. The laser medium is frequently a rod of selected material transparent to the laser radiation and the ends of this rod are highly polished, optically flat, parallel surfaces. Hence, the ends of the rod function as mirrors and define the 15 optical cavity of the laser. It is desirable in the field of laser technology to ascertain the degree of parallelism between the end faces of such a rod and to provide a method and means of quantitatively measuring the degree of parallelism or, expressed in another way, the 20 direction and angle (if any) that one of the surfaces makes with the other.

Heretofore, an optical interferometer system has been employed to detect slight motions or linear displacements of a body along a track. In one of these systems, 25 light from a laser is split, diverged and sent along two different paths to parallel oppositely facing mirrors on the body. The reflections of these beams from the mirrors on the body are superimposed and projected on a screen or they are projected on light detecting apparatus. When the body moves slightly along the track, light interference fringes move across the screen and can be viewed and detected with the apparatus. For example, these fringes which move across the screen are counted producing a count number which is a measure of the 35 linear translation of the body along the track.

Such prior systems are referred to as interferometer systems because they employ interfering light beams that produce dark and light fringes on a screen on which the beams are projected and by observing the 40 spacing, motion and displacement of these fringes, one can determine the motion and displacement of the body with reference to the track. In these systems, it is desirable that the two oppositely facing mirrors attached to the body be parallel, because deviation from parallelism 45 decreases the reliability of the system. Hence, when using such systems, one presumes that these mirrors are parallel and relies upon that conclusion when interpreting the fringes projected on the screen to determine the motion and displacement of the body with reference to 50 the track. If the mirrors are not parallel, a significant error in the measurements can occur. Clearly, when such apparatus is used as it is intended to be used, it does not reveal either the degree or the direction of non-parallelism of the two oppositely facing mirrors attached to 55 the body.

SUMMARY OF THE INVENTION

In accordance with one embodiment of the present invention, an interferometer optical system is provided 60 and used to measure the parallelism between two oppositely facing mirrors, such as the end faces of a laser rod. A beam of light from a laser is split into two beams and one beam is directed normal to one of the rod faces and the other beam is directed normal to the other face. The 65 beams reflect from the end faces of the rod and are recombined by superimposing one upon the other and the superimposed beams are projected on a screen for

viewing or they are projected on optical detection apparatus which detects light intensity. Since the light beams may be of substantially greater size, in cross-wise dimension than the end faces of the rod, some portions of the beams may not be impingent upon the end faces of the rod and yet may be superimposed and projected on the screen along with the portion of each beam which is impingent upon an end face of the rod and then superimposed and projected on the screen. Hence, the light projected on the screen may include two patterns: a smaller pattern of light from the portion of the two beams that reflect from the end faces of the rod and a larger pattern from the portion of the two beams that do not reflect from the end faces of the rod (see FIG. 12). The central region of the larger pattern will be featureless since the portion of the beam corresponding to that region is precisely that reflected by the end faces of the rod and superimposed to form the small pattern. The preferred alignment is such that the two patterns have a spacial separation of a few pattern diameters for ease of observation. However, the rod may be aligned so that the smaller pattern lies within the larger pattern as shown in FIGS. 9, 10 and 11. The larger or outer pattern reveals the alignment of the interferometer system, and consequently the various parts of the system can be adjusted while viewing this outer pattern to remove any interference fringes or lines which appear in the outer pattern and so assure that the system is perfectly aligned. Interference lines in the smaller or inner pattern reveal the angle and the direction of non-parallelism between the two end faces of the rod. Thus, a precise measure of the non-parallelism of the end faces of the rod is obtained.

Motion of the subject mirrors, as a unit, in a direction perpendicular to their surfaces results in a translation of the fringes in the smaller pattern. A count of the fringe motion is an accurate measure of the extent of motion of the mirrors. Motion in any direction not perpendicular to the mirror surfaces and/or tilting in any direction does not affect the pattern or the motion of the fringes. In the case of tilting, the entire (smaller or inner) pattern may move slightly on the screen, indicating that the mirrors are indeed tilting and not translating smoothly, but the motion of the fringes within the pattern is unaffected by the motion of the entire pattern. Such motion causes no degradation or inconvenience in the determination of either the degree of non-parallelism or extent of translation.

In one embodiment of the present invention, (FIGS. 1 and 2) where the optical paths of both the beams formed by splitting the laser beam all lie in a common place, slight tilting of the rod axis in that common plane does not degrade the reliability of the system for measuring the parallelism of the end faces of the rod. However, even slight tilting of the rod axis toward or away from that common plane will substantially reduce the reliability, because it introduces fringes in the inner pattern on the screen which cannot be distinguished from fringes cause by non-parallelism of the end faces of the rod. This is overcome by employing an additional mirror that together with adjacent perpendicular mirrors in the system form a retroreflective system or corner mirror. This corner reflector is in the path of both beams when no subject mirrors are present and in the path of one of the beams from the subject mirrors when they are introduced. A mirror in the path of the other beam from the subject mirrors is adjustable with respect to the system.

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It is an object of the present invention to provide an interferometer optical system for measuring the parallelism between two reflective surfaces.

It is another object to measure the angle between two reflective surfaces which are nearly parallel to each 5 other.

It is another object to measure the angle and the direction of the angle defined by two parallel surfaces which are nearly parallel to each other.

It is another object to provide an interferometer opti- 10 cal system for measuring the parallelism of the end faces of a rod such as used to provide the optical cavity and laser medium of an optical laser.

It is another object to provide an interferometer optical system for determining the degree of non-parallel- 15 ism of two oppositely facing aligned mirrors which are nearly parallel to each other.

It is another object to provide a split beam interferometer optical system wherein the split beams follow the same closed path in opposite directions and are then 20 superimposed and projected on a target and in which the closed path when interrupted by a pair of oppositely facing aligned mirrors causes fringes to appear in the projection which are indicative of the degree of non-parellelism of the two mirrors or relative rotation or 25 joint transational positions of the two mirrors.

It is another object in conjunction with the above to provide such an interferometer optical system wherein the measurements are not degraded due to tilting of the mirrors in other directions with respect to the normal to 30 the plane of the closed path.

DESCRIPTION OF THE DRAWINGS

FIG. 1 is a schematic drawing of an interferometer optical system which directs two split beams from a 35 laser, each over the same closed path and then superimposes the beams and projects them on a target such as a viewing screen, to illustrate the basic optical principles and structure of the present invention;

FIG. 2 is an optical schematic of the same system 40 shown in FIG. 1 and in which a rod carrying two spaced subject mirrors (reflective ends of the rod) is inserted in the closed optical path, to illustrate use of the system to measure the degree of parallelism between the two ends of the rod;

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FIG. 3 is a schematic drawing of an improved embodiment of the invention wherein the closed optical path includes a corner reflector also called a retrodirective mirror;

FIG. 4 is a schematic of the same system shown in 50 FIG. 3 and in which a subject rod having reflective end faces is inserted in the closed optical path and the system is used to determine the degree of non-parallelism between the end faces of the rod, even when the axis of the rod is tilted slightly in any direction with reference 55 to the direction of the closed path where the rod is inserted;

FIG. 5 is a plan view of the system shown schematically in FIG. 4;

FIGS. 6, 7 and 8 illustrate the projected pattern and 60 show a typical orientation of interference fringe lines as the system is progesssively adjusted without the subject rod inserted to intercept the beams in the closed optical path;

FIG. 9 illustrates the entire pattern when the system 65 in FIG. 5 is adjusted as illustrated in FIGS. 6, 7 and 8, and a subject or reference rod is inserted in the closed optical path without upsetting the rest of the system;

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FIGS. 10 and 11 illustrate the inner and outer patterns when the inserted rod does in fact slightly upset the rest of the system and steps are progressively taken to correct the system without removing the rod to reveal, by virtue of the inner pattern, the degree of non-parallelism of the end faces of the rod and the direction of the non-parallelism;

FIG. 12 illustrates the inner and outer patterns when the rod tilts, moving the inner pattern out of and away from the outer pattern without affecting the structure of either pattern; and

FIG. 13 is a schematic drawing of the improved embodiment showing vectors as an aid to understanding operation of the system.

DESCRIPTION OF EMBODIMENTS OF THE INVENTION

Referring first to FIG. 1, there is illustrated by diagram an interferometer optical system which is used for measuring the degree of parallelism of two spaced subject mirrors which may be the reflective faces at the ends of a rod which define a laser optical cavity. The system includes a monochromatic source of light that is conveniently provided by a laser 1. The laser beam 2 is a narrow parallel beam and is directed to a beam splitting mirror or pellicle M_s which is oriented with respect to the center axis of the beam and includes a semireflecting surface 3 which splits the initial laser beam into two separate beams denoted A and B. The A beam is the transmitted beam, since it goes through the semireflecting surface 3 without change in direction. The B beam is the reflected beam, since it reflects from the semi-transparent surface and so emerges from the beam splitting mirror at an angle to beam A.

The A beam impinges on mirror M₁ which is oriented at 45° to this beam and so reflects from mirror M₁ to mirror M₃ upon which the beam is also incident at 45°. Thus, the mirrors M₁ and M₃ are perpendicular to each other and they are also perependicular to the common plane defined by the path of beam A from mirrors M_s to M₁ and from mirrors M₁ to M₃. The A beam then reflects from mirror M₃ toward mirror M₄ which is disposed at an angle to the incident A beam, such that M₄ reflects the A beam back to the beam splitting mirror 45 M_s to the same spot on the semi-reflective surface 3 in that mirror which was the origin of beam A. The beam splitting mirror then splits the returned beam A, transmitting a portion of this beam without change of direction toward the target 4. The other portion of the returned beam A which is split by M_s, is directed back toward the laser and is of no use in the system.

Beam B which begins at an angle to beam A is directed from M_s to M₄, from M₄ to M₃, from M₃ to M₁ and from M₁ back to M_s. The returned beam B is split at M_s and a portion is reflected by the semi-reflective surface 3 toward the target 4. The other portion of the returned beam B is transmitted through M_s toward the laser and is of no use in the system.

Thus, the initial laser beam is split into two equal beams, the A beam and the B beam, the A beam is reflected around the optical system of mirrors in the clockwise direction, as viewed in FIG. 1 and the B beam is reflected around the system in the counter-clockwise direction. Also, the portions of beams A and B that are directed from M_s toward the target are super-imposed on each other and are denoted herein A₀ and B₀, respectively. Furthermore, where the four mirrors M_s, M₁, M₃ and M₄ are all perpendicular to the page, as

shown in FIG. 1 and the initial laser beam is parallel to the page and also parallel to the optical line from M_s to M_1 , then both beams will propogate over precisely the same paths between the mirrors, but in opposite directions and the output beams A_0 and B_0 will be perfectly 5 superimposed one upon the other and the total image of these superimposed beams at the target will have no interference lines or fringes.

Now, if two optically flat subject mirrors 5 and 6 which are perfectly parallel are inserted into the leg of 10 the optical path between mirrors M₃ and M₄ (adjusted such that the optical path between mirror 5 and M_s is similar in length to the optical path between mirror 6 and M₃) so that mirror 5 reflects the A beam and mirror 6 reflects the B beam, as shown by the broken line posi- 15 tions of these mirrors in FIG. 1, then the A and B beams will both be directed back to the same spot on the semireflective surface 3 from whence they started and a portion of the A beam will be reflected by surface 3 toward the target and a portion of the B bema will be 20 transmitted through surface 3 to the target. These two output portions of the reflected A and B beams, now denoted A_0' and B_0' , respectively, will be perfectly superimposed one upon the other and will produce no interference lines or fringes on the target. Hence, the 25 lack of any interference lines or fringes in the image of these superimposed beams A_0' and B_0' on the target indicate that the two mirrors 5 and 6 are perfectly parallel. If these mirrors 5 and 6 are the reflective ends of a rod such as used as a laser optical cavity, then the lack 30 of lines or fringes in the image at the target indicates that the reflective ends of the rod are perfectly parallel to each other.

FIG. 2 shows the same system as shown in FIG. 1 and in which the two mirrors are the reflective ends 7 and 8 35 of a subject rod 9 which is inserted into the optical path between the mirrors M_3 and M_4 . If the rod is inserted so that the reflective ends 7 and 8 are mutually tilted slightly (the rod axis is tilted) so that they are not perpendicular to the optical paths between mirrors M₃ and 40 M₄ and if the tilt angle lies in the plane of the paper, then the reflected beams A and B will not impinge on the same spot of the semi-reflective surface 3, as the original source beam. However, the output beams A_0' and B_0' will still be parallel to and coincident with each other 45 and all paths of both beams will lie in the plane of the paper. As a result, there will still be no interference fringes in the image of the output beams projected in the target. This situation will hold so long as the two reflective ends 7 and 8 of the rod 9 are absolutely parallel to 50 each other. On the other hand, even if the rod end faces are absolutely parallel, if the rod axis is tilted with respect to the plane of the paper, fringes will occur. Thus, the system shown in FIGS. 1 and 2 is useful to detect non-parallelism between the end faces of the rod, only 55 so long as all beam paths lie in the common plane and there is no tilt of the axis of the rods with respect to that common plane. Clearly, this is a serious limitation of such a system.

FIGS. 3 and 4 show a system for measuring the degree of non-parallelism between the reflective end faces of the subject rod wherein the above limitation is substantially avoided. Hence, the system shown in FIGS. 3 and 4 includes an improvement over the system shown in FIGS. 1 and 2. In both these systems shown, the parts 65 which may be identical bear the same reference designation. In FIG. 3, the improved system is shown without the subject rod inserted. The improved system includes

a mirror M₂ located in the path between mirrors M₁ and M₃. The mirrors M₁ and M₃ are inclined so as to include reflection from M₂ in the optical path. The three mirrors M₁, M₂ and M₃ are mutually perpendicular and combine to define a corner reflector, also called a retrodirective mirror or cube reflector. This system can be aligned to obtain parallel beam paths of similar lengths such that no interference fringes or lines appear on the target. The alignment is accomplished by first adjusting M₄ so that the A beam intersects itself at the M_s surface after one circuit of the system and then adjusting M_s so that no fringes appear on the screen. This makes the B beam path between M_s and M₄ coincident with the A beam path between these mirrors and, as a result, insures parallelism of the A and B beams throughout the system.

After aligning the system shown in FIG. 3, the subject or reference rod 9 is introduced in the optical path between M_3 and M_4 . If the reflective faces 7 and 8 are exactly parallel, then the superimposed output beams A_0 ' and B_0 ' projected on the target 4 will not produce any interference fringes or lines. On the other hand, if interference fringes do appear on the target in the inner pattern projected on the target (as shown in FIG. 9) it will mean that the faces 7 and 8 deviate from parallelism. Expressed in another way, the appearance of fringe lines will mean that the two emerging output beams A_0 ' and B_0 ' will not be exactly parallel, but will diverge.

If the target 4 is a screen, then the pattern projected on the screen by the output beams A_0' and B_0' will be a circle which is referred to herein as the central pattern. Radiation from beams A and B which does not reflect from the end faces 7 and 8, but in fact passes the sample 9 and returns to the point of origin of these beams in the semi-reflective layer 3 of M_s, just as though sample rod 9 where not in the circuit, will also be projected on the screen and is referred to herein as output beams A₀ and B_0 . The outputs A_0 and B_0 define a larger pattern than the outputs A_0' and B_0' . This larger pattern is referred to herein as the outer pattern and is free of interference lines when the system, not including rod 9, as in exact alignment so that the output beams A_0 and B_0 are exactly superimposed and parallel to each other. Both the inner and the outer patterns are shown in FIGS. 9 to 11 and illustrate different steps of adjustment of the system.

The complete pattern, shown in FIG. 9 indicates that the system, excluding the rod 9, is in perfedct adjustment, and that the reflective end faces 7 and 8 of the rod 9 are not exactly parallel. For example, where the diameter of the end faces is D and the central pattern as shown in FIG. 9 contains four fringe lins, then the angular deviation from parallelism of the two end faces of the rod, denoted θ , is given as follows:

 $\theta = 2 \lambda/D$

where λ is the wavelength of the laser beam. This same relationship holds true for the system shown in FIG. 2 that does not include a retrodirective mirror and so does not include M_2 . However, with the system shown in FIG. 2, the pattern shown in FIG. 9 could occur for any of the following reasons: the rod faces deviate from parallelism; the axis of the rod is not parallel to the beam path between mirrors M_3 and M_4 ; a combination of the first two reasons. It can be seen from the relationship above that with the system shown in FIG. 2, misalignments of the rod axis on the order of one minute could obscure the measure of parallelism. In other words, if

the axis of the rod were tilted with reference to the plane defined by the beam paths (the plane of the paper) by an angle of one minute, fringes would appear in the central pattern on the screen due to the tilt. Thus, it would be impossible to tell whether the fringes were 5 caused by the tilt or by non-parallelism between the two reflective end faces of the rod 9.

In many uses of the interferometer systems described herein for measuring the degree of parallelism between two optically flat mirrors, it is impractical to require 10 that the axis of the two mirrors be placed precisely in the system, because there is no simple method of accurately determining the alignment of that axis with the beam path. More particularly, where the two subject mirrors are the reflecting end faces of a laser rod, it is 15 impractical to require that the rod be precisely placed in the interferometer optical system, because there is no simple method of accurately determining the rod axis or the alignment of that axis with the beam path between the mirrors M_3 and M_4 . Hence, it is of considerable 20 advantage to use the improved system described herein with reference to FIGS. 3 and 4, in which fringes appearing in the central or smaller pattern are attributable only to non-parallelism of the two end faces of the rod. In this improved system, the rod axis can be tilted 25 slightly in any direction relative to the beam path between the mirrors M₃ and M₄ without significantly changing the parallelism of the output beams A₀' and $\mathbf{B_0}'$.

FIG. 5 illustrates the same system shown in FIG. 4 30 laid out on a platform 10. Parts in the system shown in FIG. 5 which are equivalent to the system in FIG. 4 bear the same reference designation. Here, the system is illustrated without the subject rod inserted in the optical circuit. All parts of this system are mounted on an opti- 35 cal platform 10 and a holder 11 is provided for holding the test rod. In addition, a beam expander 12 is provided between laser 1 and the beam splitting mirror M_s. Also, a camera 13 may be mounted on the platform for recording the projected patterns on the film. FIGS. 6 to 40 12 illustrates the patterns that are projected on the screeen and are referred to herein as an aid to understanding the use and operation of the system to measure the degree of parallelism, or lack of parallelism, between the reflective end faces of the subject rod.

In operation, this system is used in the following manner:

- 1. First the laser is turned on and the beam expander 12 is removed from the path of the laser beam 2.
- 2. Then the laser beam direction is adjusted so that the 50 laser beam 2 strikes M_s near its center.
- 3. Then M_s and M_4 are adjusted in position by positioning screws (not shown) so that the system beams, A and B, return to M_s at the point of incidence of beam 2 and the two laser spots from output beams A_0 and B_0 55 coalesce on the screen.
- 4. Then the beam expander 12 is inserted in the system and M_4 is adjusted until the pattern on the screen is free of fringes. At first, this large pattern will show many fringe lines. These disappear as M_4 is adjusted. As M_4 is 60 adjusted, the fringes separate and/or rotate in the pattern and separate until they are spaced so far apart from each other than none fall within the diameter of the large pattern.
- 5. Then the subject rod (not shown) is inserted in the 65 holder 11 and visually aligned in the system between M₃ and M₄. At this point, the pattern on the screen should be as illustrated in FIG. 9 (though the patterns

may be separated as in FIG. 12), provided, however, that the system has not been put out of alignment when the rod is inserted.

As already described, each fringe line in the central pattern corresponds to a deviation from parallelism of the rod of one-half wavelength of the laser radiation. Hence, the four fringe lines shown in the central pattern in FIG. 9 correspond to an angular deviation θ from parallelism of 2 λ /D radians. For example, where the rod diameter is one centimeter and $\lambda = 6328$ Angstroms, then the angular deviation from parallelism is 1.3×10^{-4} radians or approximately 0.43 minutes of angle.

If upon inserting the rod in the system, shown in FIG. 5, the outer pattern now shows fringe lines, it means that the system excluding the rod has been put out of alignment. This is illustrated by the inner and outer patterns shown in FIG. 10. If this occurs, then M_4 is again adjusted (step 4) so that the outer pattern fringes expand. After adjustment of M_4 , count the number of fringe lines appearing in the inner pattern and calculate the angular deviation from parallelism of the rod.

To determine the sense of the deviation from parallelism, the following analysis is made: (a) If the fringes are nearly horizontal, then to determine whether the top of the laser rod is longer than the bottom or vice versa, M_4 may be tilted slightly upward and if the fringes expand, the top of the rod is longer and if the fringes contract, the top is shorter. (b) If the fringes are nearly vertical, then to determine whether the outside of the rod is longer than the inside or vice versa, M_4 may be rotated clockwise and if the fringes expand, the outside of the rod is longer than the inside and if the fringes contract, the inside is longer than the outside.

The improved system, shown in FIGS. 3 to 5 includes the mirror M_2 so that M_1 and M_2 and M_3 combine to form a corner reflector or retrodirective mirror. This eliminates errors in the system due to tilt of the sample as described. A rigorous analysis of the system can be made to show that this is accomplished. The following analysis shows that the addition of M_2 in the system as described will, in fact, eliminate errors due to the tilt of the rod with reference to the plane of the system, and consequently the system will be insensitive to any tilt of the rod.

A sample rod inserted into a suitably aligned system at an angle β to the beam path between M_3 and M_4 results in two beams A_0' and B_0' at an angle α , ($\alpha = 2\beta$), to the uninterrupted beams A₀ and B₀ (system aligned as in FIG. 4, with rod 9 slightly misaligned). The resulting pattern from A_0' and B_0' is due to the non-parallelism of the rod end faces and also partially due to the misalignment of the rod in the apparatus. To determine the portion of the pattern due to the misalignment and demonstrate that it is negligible, it should be noted that an exit beam at an angle α to the uninterrupted beams A_0 and B₀ may be affected without inserting a rod by simply turning the laser source beam an angle α . The change in pattern due to turning the laser beam by an angle α will lead to a fringe pattern just equal to that a parallel-faced rod misaligned by an angle β .

Using vector algebra with \overline{M} being unit vectors of mirror normals and \overline{r} being unit vector path directions as shown in FIG. 13, and with mirrors M_1 , M_2 , M_3 aligned as a corner cube then

$$\overrightarrow{M}_1 \cdot \overrightarrow{M}_2 = \overrightarrow{M}_1 \cdot \overrightarrow{M}_3 = \overrightarrow{M}_2 \cdot \overrightarrow{M}_3 = 0.$$

This can easily be done to within a few minutes of arc so that the mirrors are actually aligned as $\overline{M}_1 + \overline{\epsilon}_1$, $\overline{M}_2 + \overline{\epsilon}_2$, \overline{M}_3 (reference mirror) where $|\epsilon|/|M| < 0.01$.

Consider the beam r_0 , r_1 , r_2 , r_3 depicted in FIG. 13 and apply the mirror equation $r_{new} = \vec{r}_{old} - 2[\vec{M} \cdot \vec{r}_{old}]\vec{M}$. So

$$\overrightarrow{r_1} = \overrightarrow{r_0} - 2[(\overrightarrow{M_1} + \overrightarrow{\epsilon_1}) \cdot \overrightarrow{r_0}](\overrightarrow{M_1} + \overrightarrow{\epsilon_1})$$

$$\overrightarrow{r_1} = \overrightarrow{r_0} - 2[(\overrightarrow{M_1} \cdot \overrightarrow{r_0} + \overrightarrow{\epsilon_1} \cdot \overrightarrow{r_0})](\overrightarrow{M_1} + \overrightarrow{\epsilon_1})$$
 (1)

and

or

$$\overrightarrow{r_2} = \overrightarrow{r_1} - 2[(\overrightarrow{M_2} + \overrightarrow{\epsilon_2}) \cdot \overrightarrow{r_1}](\overrightarrow{M_2} + \overrightarrow{\epsilon_2})$$

and substituting Eq. (1)

$$\overrightarrow{r_2} = \overrightarrow{r_0} - 2(\overrightarrow{M_1} \cdot \overrightarrow{r_0} + \overrightarrow{\epsilon_1} \cdot \overrightarrow{r_0}) (\overrightarrow{M_1} + \overrightarrow{\epsilon_1}) - 2((\overrightarrow{M_2} + \overrightarrow{\epsilon_2}))$$

$$\cdot [\overrightarrow{r_0} - 2(\overrightarrow{M_1} \cdot \overrightarrow{r_0} + \overrightarrow{\epsilon_1} \cdot \overrightarrow{r_0}) (\overrightarrow{M_1} + \overrightarrow{\epsilon_1})] (\overrightarrow{M_2} + \overrightarrow{\epsilon_2}).$$

Therefore,

$$\overrightarrow{r_2} = \overrightarrow{r_0} - 2 (\overrightarrow{M_1} \cdot \overrightarrow{r_0}) \overrightarrow{M_1} - 2 (\overrightarrow{\epsilon_1} \cdot \overrightarrow{r_0}) \overrightarrow{M_1} - 2 (\overrightarrow{M_1} \cdot \overrightarrow{r_0}) \overrightarrow{\epsilon_1} - 2 \{\overrightarrow{M_2} \cdot (\overrightarrow{r_0} - 2(\overrightarrow{M_1} \cdot \overrightarrow{r_0}) \overrightarrow{M_1} - 2(\overrightarrow{\epsilon_1} \cdot \overrightarrow{r_0}) \overrightarrow{M_1} - 2(\overrightarrow{M_1} \cdot \overrightarrow{r_0}) \overrightarrow{M_1} - 2(\overrightarrow{M_1} \cdot \overrightarrow{r_0}) \overrightarrow{M_1} - 2(\overrightarrow{\epsilon_1} \cdot \overrightarrow{r_0}) \overrightarrow{M_1} - 2(\overrightarrow{\epsilon_1} \cdot \overrightarrow{r_0}) \overrightarrow{M_1} - 2(\overrightarrow{\epsilon_1} \cdot \overrightarrow{r_0}) \overrightarrow{M_1} - 2(\overrightarrow{M_1} \cdot \overrightarrow{r_0}) \overrightarrow{k_1} - 2(\overrightarrow{M_1} \cdot \overrightarrow$$

wherein terms of second order in ϵ , such as $[-2(\overline{\epsilon_1}, r_0)\overline{\epsilon_1}]$, have been neglected. Eq. (2) becomes

$$\overrightarrow{r_2} = \overrightarrow{r_0} - 2(\overrightarrow{M_1}. \overrightarrow{r_0})\overrightarrow{M_1} - 2(\overrightarrow{\epsilon_1}. \overrightarrow{r_0})\overrightarrow{M_1} - 2(\overrightarrow{M_1}. \overrightarrow{r_0})\overrightarrow{\epsilon_1} - 2(\overrightarrow{M_2}. \overrightarrow{r_0})\overrightarrow{M_2} + 4(\overrightarrow{M_1}. \overrightarrow{r_0})\overrightarrow{M_2}. \overrightarrow{\epsilon_1})\overrightarrow{M_2} - 2(\overrightarrow{\epsilon_2}. \overrightarrow{r_0})\overrightarrow{M_2} + 4(\overrightarrow{M_1}. \overrightarrow{r_0}) (\overrightarrow{M_1}. \overrightarrow{\epsilon_2})\overrightarrow{M_2} - 2(\overrightarrow{M_2}. \overrightarrow{r_0})\overrightarrow{\epsilon_2}$$

to first order. Note that $4(M_2 \cdot M_1) \cdot (M_1 \cdot r_0) \epsilon_2 = 0$ since $(M_2 \cdot M_1) = 0$. Similar terms do not appear in Eq. (3). Further, $\vec{r}_3 = \vec{r}_2 - 2(M_3 \cdot \vec{r}_2) \vec{M}_3$; and using Eq. (3) to substitute for \vec{r}_2 in the expression $-2(M_3 \cdot \vec{r}_2) \vec{M}_3$ leads to

$$\overrightarrow{r_3} = \overrightarrow{r_2} - 2\{\overrightarrow{\mathbf{M}_3}. \overrightarrow{[r_0 - 2(\overrightarrow{\mathbf{M}_1}. \overrightarrow{r_0})\overrightarrow{\epsilon_1} - 2(\overrightarrow{\mathbf{M}_2}. \overrightarrow{r_0})\overrightarrow{\epsilon_2}]}\}\overrightarrow{\mathbf{M}_3}$$

to first order. Therefore

$$\overrightarrow{r_3} = \overrightarrow{r_0} - 2\overrightarrow{r_0} - 2(\overrightarrow{\epsilon_1} \cdot \overrightarrow{r_0})\overrightarrow{M_1} - 2(\overrightarrow{M_1} \cdot \overrightarrow{r_0})\overrightarrow{\epsilon_1} + 4(\overrightarrow{M_1} \cdot \overrightarrow{r_0})\overrightarrow{(M_2} \cdot \overrightarrow{\epsilon_1})\overrightarrow{M_2} - 2(\overrightarrow{\epsilon_2} \cdot \overrightarrow{r_0})\overrightarrow{M_2} + 4(\overrightarrow{M_1} \cdot \overrightarrow{r_0}) (\overrightarrow{M_1} \cdot \overrightarrow{\epsilon_2})\overrightarrow{M_2} - 2(\overrightarrow{M_2} \cdot \overrightarrow{r_0})\overrightarrow{\epsilon_2} + 4(\overrightarrow{M_1} \cdot \overrightarrow{r_0}) (\overrightarrow{M_3} \cdot \overrightarrow{\epsilon_1}) \overrightarrow{M_3} + 4(\overrightarrow{M_2} \cdot \overrightarrow{r_0}) (\overrightarrow{M_3} \cdot \overrightarrow{\epsilon_2})\overrightarrow{M_3}$$

since

$$-\overrightarrow{2r_0} = -2(\overrightarrow{M}_1 \cdot \overrightarrow{r_0})\overrightarrow{M}_1 - 2(\overrightarrow{M}_2 \cdot \overrightarrow{r_0})\overrightarrow{M}_2 - 2(\overrightarrow{M}_3 \cdot \overrightarrow{r_0})\overrightarrow{M}_3.$$

and finally,

$$\vec{r}_3 = -\vec{r}_0 + \vec{f}(\vec{\epsilon}_1, \vec{\epsilon}_2) \tag{4}$$

where $f(\epsilon_1, \epsilon_2)$ is the sum of several (namely, 8) terms of the form $A(|\vec{\epsilon}||\vec{r_0}|)\vec{\nu}$ in which $\vec{\nu}$ is a unit vector and A is the appropriate term coefficient multiplied by the cosines indicated by the dot products; i.e., the 5th term in Eq. (3a) is $4(\vec{M_1} \cdot \vec{r_0}) (\vec{M_2} \cdot \vec{\epsilon_1}) \vec{M_2}$ in which case $\vec{\nu}$ is $\vec{M_2}$ and $\vec{A} = 4 \cos \theta \cos \Phi$ wherein θ is the angle between $\vec{M_1}$ and $\vec{r_0}$, and $\vec{\Phi}$ is the angle between $\vec{M_2}$ and $\vec{\epsilon_1}$. Thus, the 5th term in Eq. (3a) is $4 \cos \theta \cos \Phi (|\epsilon_1||r_0|) \vec{M_2}$. These terms are all of the order ϵ and the sum of all these terms is $A_{\epsilon}(|\epsilon_t||r_0|)\vec{\nu_t}$ where the subscript, t, indi-

cates the results of vector addition. We now have $\vec{r}_3 = -\vec{r}_0 + A_t(\vec{\epsilon}_t, \vec{r}_0)\vec{\nu}_t$ from Eq. (4).

Now denoting the entire clockwise travelling beam (A), it is clear that M_s and M_4 may be adjusted such that the counterclockwise travelling beam (B) may be adjusted to be parallel and opposite (antiparallel) to (A). In this case, (B) in the M_3-M_4 leg must have the form $R = + r_0 - A_B$ (ϵ_B . r_0) v_t to be antiparallel and in addition

$$\overrightarrow{A_t(\epsilon_t, r_0)\nu_t} = \overrightarrow{A_B(\epsilon_B, r_0)\epsilon_t}$$
 (5)

for this particular \vec{r}_0 .

Now introduce a deviation in r_0 of an amount such that $r_0 = r_0 + Z$. Then the clockwise beam (A) in leg $M_3 - M_4$ is $r_3 = -(r_0 + Z) + A_t[\epsilon_t \cdot (r_0 + Z)]\nu_t$ or $r_3 = -(r_0 + Z) + A_t(\epsilon_t \cdot r_0)\nu_t + A_t(\epsilon_t \cdot Z)\nu_t$ (6)

and the counterclockwise beam (\overrightarrow{B}) in leg M_3 - M_4 is

$$\overrightarrow{R} = \overrightarrow{r_0} + \overrightarrow{Z} - \overrightarrow{A_B[\epsilon_B} \cdot (\overrightarrow{r_0} + \overrightarrow{Z})]\overrightarrow{\nu_t}$$

or

(3) 35

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(3a)

$$\overrightarrow{R} = \overrightarrow{r_0} + \overrightarrow{Z} - A_B(\overrightarrow{\epsilon}_B \cdot \overrightarrow{r_0})\overrightarrow{\nu}_t - A_B(\overrightarrow{\epsilon}_B \cdot \overrightarrow{Z})\overrightarrow{\nu}_t \qquad (7)$$

The deviation in parallelism due to the change in \vec{r}_0 by \vec{Z} is just the difference between Eqs. (6) and (7):

Dev
$$= \overrightarrow{r}_3 + \overrightarrow{R} = A_t(\overrightarrow{\epsilon_t}, r_0)\nu_t + A_t(\overrightarrow{\epsilon_t}, \overrightarrow{Z})\overrightarrow{\nu_t} - A_B(\overrightarrow{\epsilon_B}, \overrightarrow{r_0})\overrightarrow{\nu_t}$$

 $- A_B(\overrightarrow{\epsilon_B}, \overrightarrow{Z})\overrightarrow{\nu_t}$ (8)

From Eq. (5), the first and third terms in Eq. (8) vanish and Eq. (8) can be written

$$Dev = [A_{l}(\vec{\epsilon}_{l}, \vec{Z}) - A_{B}(\vec{\epsilon}_{B}, \vec{Z})]\vec{\nu}_{l}$$
 (9)

and, therefore, the deviation is of the order $(|\epsilon||Z|)$.

This means that a beam misalignment of 5° or 0.1 rad, for example, (corresponding to a rod misalignment of 2.5° or 0.05 rad) with mirror misalignments of one minute or 0.0003 rad introduces a total error of the order of $Z\epsilon = (0.1) (0.0003)$ rad or approximately ten seconds of spurious deviation from parallelism. For a 1 cm. diameter rod, one fringe is

$$\lambda/2$$
 D = $(0.63 \times 10^{-4})/(2) = 0.32 \times 10^{-4}$

approximating ten seconds of arc, and, consequently, a rod misalignment as large as 2.5° results in approximately 1 fringe in a 1 cm. field of view.

This preferred apparatus, therefore, will accommodate rod misalignments up to 2.5° without introducing an error in the measurement of parallelism greater than a few seconds of arc.

Both of the systems described herein, that is the system shown in FIGS. 1 and 2 and the improved system shown and described with references to FIGS. 3 to 13, are used to determine the degree of parallelism or non-parallelism of two subject mirrors. Furthermore, these systems are particularly useful for determining the degree of parallelism between the reflective end faces of a laser rod. Other and similar uses include the following: The systems can be used in conjunction with with Fabry-Perot fringes of a rod itself. For example, a rod with poor homogeneity and good parallelism of end faces will show Fabry-Perot fringes and is not a good rod and should be discarded. However, a rod with good homogeneity and poor parallelism will also show

Fabry-Perot fringes but simply needs polishing. The rods may be measured jointly by use of a Fabry-Perot apparatus and also by use of the interferometers described in the present invention. Rods may also be continuously monitored with a joint apparatus to determine 5 both the rod refractive index variation and distortion of the rod end faces. Also, infra-red laser rods may be measured with either of the systems of the present invention using visible laser light to determine their optical characteristics to a higher precision than if the char- 10 wherein, acteristics were measured with infra-red radiation.

The optical systems of the present invention can also be used to measure the degree of parallelism of the ends of non-transparent optical devices such as gage blocks. Very slight rotations of one body with reference to 15 another body can be determined by mounting one of the two subject mirrors on one body and mounting the other mirror on the other body so that the two mirrors are spaced apart, facing in opposite directions and are substantially parallel. It is then only necessary to note 20 the change in the number of fringes in the inner pattern to determine slight changes in the angular position of one body with respect to the other.

The optical systems of the present invention may also be used to measure motion in a direction perpendicular 25 wherein, to the end faces. Fringes traverse the inner pattern when the rod is moved in this direction. Motion or rotation in any other independent direction has no affect on the motion of the fringes in the pattern.

In the preferred embodiment of the present invention 30 shown in FIGS. 3 to 13, the three mirrors M₁, M₂ and M₃ which are mutually perpendicular and define a cube reflector can be provided in a number of different ways. For example, they can be provided as three separate mirrors just as described herein, or they can be pro- 35 vided by a solid glass corner cube called a retroreflector prism in which three internal faces are made totally reflective. This variation and other variations of the system described herein can be made by one skilled in the art without deviating from the spirit and scope of 40 the invention as set forth in the appended claims.

What is claimed is:

1. An interferometer optical system for measuring the positions of first and second space subject mirrors comprising,

a source of coherent radiation directed along an initial path,

a target for the radiation,

means in said path for splitting said radiation into two substantially equal beams, a first beam and a second 50 beam,

first optical means including first, second and third mutually perpendicular mirrors for directing the first beam normal to the first spaced mirror,

second optical means for directing the second beam 55 normal to the second spaced mirror,

the first optical means serving to direct the first beam which reflects from the first spaced mirror back to the beam splitting means,

the second optical means serving to direct the second 60 beam which reflects from the second spaced mirror back to the beam splitting means, and

at said beam splitting means, at least a portion of said reflected first and second beams are superimposed and directed to said target,

whereby light patterns appearing on the target are indicative of the positions of the first and second subject mirrors.

2. An interferometer optical system as in claim 1 wherein,

the spaced subject mirrors are fixed with respect to each other and

a change in said light patterns accompanying a change in the position of said spaced subject mirrors in the direction of the beams incident thereon is indicative of said change in position.

3. An interferometer optical system as in claim 1

one of the spaced subject mirrors is rotatably moveable with respect to the other and

a change in said light patterns accompanying a rotation of the position of one of said spaced subject mirrors with respect to the other is indicative of said rotation.

4. An interferometer optical system as in claim 1 wherein,

the spaced subject mirrors are translatably moveable with respect to each other and

a change in said light patterns accompanying a change in the position of said spaced subject mirrors is indicative of said translation.

5. An interferometer optical system as in claim 1

the first beam from the beam splitting means is the same direction as the initial laser beam,

the second beam from the beam splitting means is at an angle to the initial laser beam, and

the first and second spaced subject mirrors are oppositely facing.

6. An interferometer optical system as in claim 1 wherein, said first and second beams are so sized with respect to said two subject mirrors such that a portion of the first beam and a portion of the second beam

pass and do not reflect from the two subject mirrors, such portion of the first beam is directed back to the beam

splitting means by the second optical means, such portion of the second beam is directed back to the beam splitting means by the first optical means, and said portions are directed from the beam splitting means,

one superimposed upon the other along a common output path to the target providing an outer light pattern on the target and

said outer light pattern is indicative of the degree of misalignment of the first, third, and fourth mirrors relative to the beam splitting means and the initial path of the laser radiation.

7. An interferometer system as in claim 1 wherein, the common output path is parallel to the initial direction of the second beam from the beam splitting means.

8. An interferometer optical system for measuring the optical parallelism of first and second spaced subject mirrors comprising,

a source of spacially coherent radiation directed along an initial path,

a target for said radiation,

means for splitting said radiation along said initial path into two beams, a first beam and a second beam,

first optical means for directing the first beam normal to said first subject mirror,

second optical means for directing said second beam normal to the second subject mirror,

the first optical means includes first, second and third mutually perpendicular mirrors which intercept the

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first beam from the beam splitting means and combines with said beam splitting means and said first spaced mirror to define a first optical path,

the second optical means includes a fourth mirror which intercepts the second beam from the beam 5 splitting means and combines with said beam splitting means and the second subject mirror to define a second optical path,

the first, second, third and fourth mirrors and the beam splitting means, without the two spaced mir- 10 rors in the system, define a closed optical path for both the first and the second beams over which these beams each return to a point of origin at the

beam splitting means, whereat the returned first and second beams are superimposed one upon the other and directed along a common output path to the target and

said two subject mirrors are located along said closed path between the third and fourth mirrors,

whereby when said two spaced mirrors are so placed in the system, the superimposed first and second beams along the common output path directed to the target reveal an interference pattern which is indicative of the degree of non-parallelism of the two spaced mirrors.

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